

**STATEMENT UNDER 37 CFR § 3.73(b)**  
**ESTABLISHMENT OF ASSIGNEE**

Applicant	:	Raffaele Zambrano
App. No.	:	09/191,743
Filed	:	November 13, 1998
For	:	IN-SITU DEPOSITION AND DOPING PROCESS FOR POLYCRYSTALLINE SILICON LAYERS AND THE RESULTING DEVICE
Examiner	:	Mandala, Michelle
Group Art Unit	:	2823
Conf. No.	:	8970

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This document is being filed with a copy of a Power of Attorney signed by the Assignee. This Statement sets forth the chain of title of the above-identified application.

MICRON TECHNOLOGY, INC., a corporation, is the Assignee of the entire right, title, and interest of the above-referenced application by virtue of:

A chain of title from the inventor(s) to the current Assignee as shown by the following recorded assignments:

1. Assignment from Raffaele Zambrano to STMICROELECTRONICS S.R.L. recorded in the United States Patent and Trademark Office on February 08, 1999, at Reel 009760, and Frame 0763.
2. Assignments conveying title from STMICROELECTRONICS S.R.L. (formerly known as SGS-THOMSON MICROELECTRONICS S.R.L.) to MICRON TECHNOLOGY, INC. recorded in the United States Patent and Trademark Office on August 31, 2012, at Reel 028888, and Frame 0624.

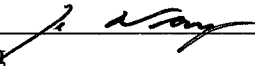
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Docket No. MICRON.434A  
Customer No. 107,157

The undersigned is an agent of Customer Number 107,157 and is authorized to act on behalf of the Assignee. Please recognize or change the correspondence address for the above-identified application to **Customer No. 107,157.**

Respectfully submitted,  
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: September 07, 2012

By:   
Zi Y. Wong  
Registration No. 58,410  
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